

**PATENT ASSIGNMENT**

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Nam Hun Kim	09/15/2006
RECEIVING PARTY DATA	
Name:	Adaptive Plasma Technology Corp.
Street Address:	352-1 Ichi-ri, Majang-myeon
City:	Icheon-si, Gyeonggi-do 467-813
State/Country:	KOREA, REPUBLIC OF
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	10593857
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ATTORNEY DOCKET NUMBER:	58409/N305
NAME OF SUBMITTER:	D. Bruce Prout
Total Attachments: 1 source=58409 Assignment#page1.tif	

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Docket No.: 58409/N305

Return to:  
CHRISTIE, PARKER & HALE  
Post Office Box 7068  
Pasadena, CA 91109-7068

**ASSIGNMENT**

In consideration of good and valuable consideration, the receipt of which is hereby acknowledged, the undersigned,

(1) Nam Hun Kim

HEREBY SELL(S), ASSIGN(S) AND TRANSFER(S) TO

(2) Adaptive Plasma Technology Corp.

having a place of business at

(3) 352-1 Ichi-ri, Majang-myeon, Icheon-si, Gyeonggi-do 467-813, Republic of Korea

(hereinafter called "ASSIGNEE") the entire right, title and interest in and to any and all improvements which are disclosed in the application for United States Letters Patent entitled

(4) PLASMA CHAMBER HAVING PLASMA SOURCE COIL AND METHOD FOR ETCHING THE WAFER USING THE SAME

which application was:

(a) executed on (5a): \_\_\_\_\_;

(b) filed on (5b): September 22, 2006;

Application No.: 10/593,857

(CHRISTIE, PARKER & HALE, LLP, P.O. Box 7068, Pasadena, CA 91109-7068) is hereby authorized to insert in (b) the specified data, when known.

including any and all United States Patents which may be granted on said application, and any and all extensions, divisions, reissues, substitutes, renewals or continuations of said application and patents, and the right to all benefits under all international conventions for the protection of industrial property and applications for said improvements.

It is hereby authorized and requested that the Commissioner of Patents issue any and all of said Letters Patent, when granted, to said ASSIGNEE, its assigns or its successors in interest or its designee.

Upon said consideration, it is further agreed that, when requested, without charge to but at the expense of said ASSIGNEE, the undersigned will execute all divisional, continuing, substitute, renewal, and reissue patent applications; execute all rightful other papers; and generally do everything possible which said ASSIGNEE shall consider desirable for aiding in securing and maintaining patent protection as provided herein.

**INVENTOR(S)**

Nam Hun Kim

**SIGNATURE**

x NHK

**DATE**

x sep 15, 2006

**WITNESSES:**

Heung Gyoungwon

CHOI, Ji-ma

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